

If $\mathbf{j} \rightarrow$ current density within the fluid ³⁾

$P \rightarrow$ fluid pressure

$$\mathbf{F} = \mathbf{j} \times \mathbf{B} - \nabla P \quad (1)$$

\hookrightarrow Fundamental eqⁿ of MHD

using $\nabla \times \mathbf{B} = \mu_0 \mathbf{j}$

$$\begin{aligned} \mathbf{F} &= -\frac{\mathbf{B}}{\mu_0} \times (\nabla \times \mathbf{B}) - \nabla P \\ &= -\nabla \left(\frac{B^2}{2\mu_0} \right) + \frac{1}{\mu_0} (\mathbf{B} \cdot \nabla) \mathbf{B} - \nabla P \\ &= \frac{1}{\mu_0} (\mathbf{B} \cdot \nabla) \mathbf{B} - \nabla \left(P + \frac{B^2}{2\mu_0} \right) \quad (2) \end{aligned}$$

for equilibrium $\mathbf{F} = 0$, and hence, if the first term vanishes as is the case of current sheet

$$P + \frac{B^2}{2\mu_0} = \text{constant} \quad (3)$$

Conditions of stable equilibrium

Magnetic Confinement - Pinch Effect

From eqⁿ (1) for equilibrium $\mathbf{F} = 0$

$$\nabla P = \mathbf{j} \times \mathbf{B} \quad (4)$$

Scalar product with \mathbf{B} and \mathbf{j}

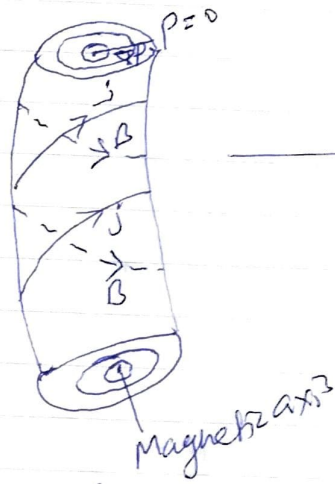
$$\mathbf{B} \cdot \nabla P = \mathbf{B} \cdot (\mathbf{j} \times \mathbf{B}) = 0 \quad (5)$$

and

$$\mathbf{j} \cdot \nabla P = \mathbf{j} \cdot (\mathbf{j} \times \mathbf{B}) = 0 \quad (6)$$

⇒ Both B and J lie on surfaces of constant pressure

If these surfaces happen to be closed, no B lines or J -lines can cross them,



→ Surfaces made up from a winding of B lines and J -lines

In these isobaric surfaces → pressure increases from outside towards the axis

Force $j \times B$ also points towards the axis. Plasma is contained by the $j \times B$ forces.

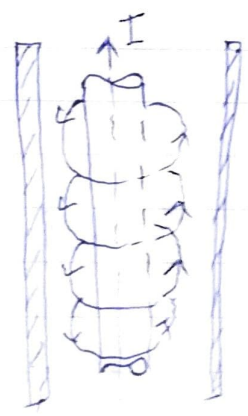
↳ Magnetic confinement

Magnetic field affect the dynamical state of a plasma

I → flowing through it axially

B → azimuthal field lines

$j \times B$ → directed towards axis which tend to "pinch" or squeeze the plasma.



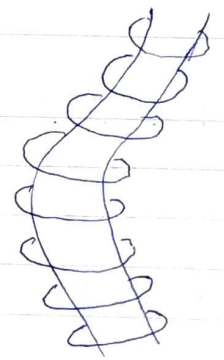
Under the effect of this force the plasma contracts

until the compressing electrodynamic force is compensated by the increased kinetic pressure $p = NkT$.

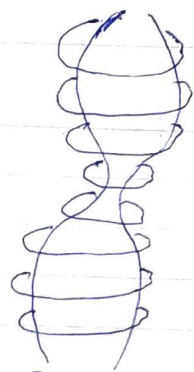
This phenomenon → "Pinch Effect"

Instabilities

No stable equilibrium pinch.



→ Kink instability
linear pinch is bent due to
some perturbation



Sausage instability
Plasma columns are pinched by
chance

$B \propto \frac{1}{r}$, the pressure $\frac{B^2}{2\mu_0}$ is greater in the
squeezed regions, i.e. at the neck → further pinching
→ ultimately disrupting the column.

Several other kinetic instabilities → either
by chance or by artificial deviation of the
distribution of particles from Maxwellian distribution.

To get over the difficulty of instability →
various schemes for containing plasma

One such system → Tokamak

An axially symmetric toroidal system → plasma
is contained by the magnetic field of the current
which flows along its axis



Tokamak → most developed magnetic confinement system 34

JET → Joint European Torus

* Plasma contained in a vacuum vessel.

Vacuum maintained by external pumps

Plasma is created by letting a small puff of gas, which is heated by driving a current through it.

* Hot plasma → contained by a magnetic field

Combination of two sets of magnetic coils → Toroidal and poloidal field coils → creating field in both vertical and horizontal directions

→ Magnetic Cage.

* Large power supplies → to generate magnetic field and plasma current

* Additional plasma heating → Neutral beam injection (NBI) → neutral hydrogen atoms at high speed

Methods of Laboratory Plasma Production

LTE → Local Thermal Equilibrium

Three types of plasmas;

Glou discharge (GD)

Inductively coupled plasma (ICP)

Microwave-induced plasma (MIP)

Commonly used in plasma spectro-chemistry.

Direct current (d.c) glow discharge

Sufficiently high potential difference \rightarrow
between two electrodes placed in a gas
Gas \rightarrow breakdown into positive ions and
electrons \rightarrow giving rise to a
gas discharge.

Few electrons are emitted from the electrode
due to the omnipresent cosmic radiation.

Potential difference applied \rightarrow electrons are
accelerated and collide with the gas atoms.

Inelastic collisions \rightarrow leading to excitation
and ionization

Excitation collisions \rightarrow followed by de-excitation
 \rightarrow emission of radiation \rightarrow glow discharge

Ionization collisions \rightarrow Create new electrons and ions

Ions \rightarrow accelerate towards cathode \rightarrow release
new electrons by ion induced secondary
electron emission

Electrons \rightarrow giving rise to new ionization
collisions \rightarrow creating new ions &
electrons.

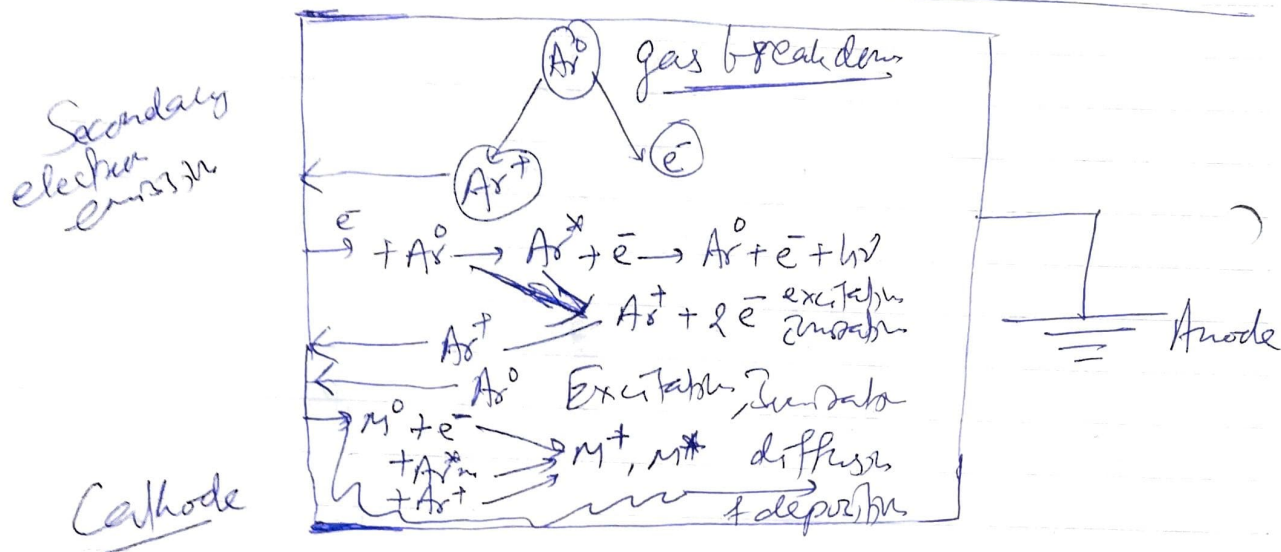
Electron emitter at cathode \rightarrow ionization in
plasma \rightarrow glow discharge \rightarrow self-sustaining
plasma.

Sputtering → sufficiently high voltages

↳ This of fast atoms from plasma bombard cathode

↳ release atoms of cathode material

↓
Useful in material technology



- * Capacitively coupled (CC) radio-frequency discharges
- * Pulsed glow discharges
- * Atmospheric pressure glow discharges (APGDs)
- * dielectric barrier discharges (DBDs)
- * Corona discharges

Dielectric barrier discharge :- AC voltage

from 1-100 kV with frequencies 50 Hz to 1 MHz applied between two electrodes with a dielectric barrier in between, operating pressure range of 0.1 - 1 atm.

RF discharges → Plasma breakdown induced by RF range of frequencies generally from 1-100 MHz.

(A) Capacitively coupled :- RF power in the frequency range of 1 kHz - 100 MHz is applied on two electrodes in the pressure range of 10^{-5} - 10^{-4} atm.

Two electrodes and their sheaths form a capacitor

(B) Inductively Coupled :- This discharge is excited by an electric field generated by a transformer from an RF current in a conductor which is wound axially around a cylindrical dielectric plasma vessel. The power in the frequency range between 1-100 MHz is coupled in the discharge by the transformer action.

(C) Helicon discharges :- electrodeless wave heated discharge

Dielectric cylinder surrounded by magnetic coils forms the plasma chamber → RF powered antenna launches the wave, that propagates along the tube and create plasma by wave-particle interaction

Microwave discharges

Microwave induced plasmas \rightarrow all the discharges created by injection of microwave power in the frequency range of 300 MHz to 10 GHz.

Cavity induced plasmas

Free expanding atmospheric plasma torches

Surface wave discharges (SWD)

electron-cyclotron resonance (ECR) plasmas

Wide range of conditions

Pressure range of 10^{-6} atm — few atm

Power of few W to several hundreds of kW